

# 電界効果によるグラフェンの 電気伝導変調

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@Lab.

# Exciting Material, Graphene !



K. S. Novoselov et al. Science 306 (2004) 666. The pioneering work in Manchester Univ.

# Outline

### 1. Graphene Introduction

# 2.Electric Field Effects in Graphene

# **3.**Possible Applications

# 4. Summary and Future Outlook

# Graphene





TEM on 90 nm-thick SiO<sub>2</sub> @Lab.

# A. H. Castro Neto et al., Rev. Mod. Phys. 81(2009)109.

# E - k Dispersion and Density of States



### Unique E-k dispersion and density of states.

## **Advanced Peeling Technique !**





# **Optical Contrast of Graphene on SiO<sub>2</sub>/Si**



#### A monolayer graphene on ~90 nm SiO<sub>2</sub> is also visible by optical microscope.

## **Conventional FET and Graphene FET**



## Graphite to Graphene on SiO<sub>2</sub>



K. Nagashio et al., JJAP 49 (2010).

#### Monolayer graphene is something special.

VLSI Tech Short Course

## Graphene on Nothing and on BN

#### Suspended





#### On BN



a)



1.7% lattice mismatch

#### K. I. Bolotin et al., SSC 146 (2008) 351.

### Mobility Limited by Interfacing Substrate



### **Possible Scattering Mechanisms**



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J-H Chen et al., Nature Nano. 3 (2008) 206.

# **Graphene / SiO<sub>2</sub> Interaction**



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### The flake size depends on SiO<sub>2</sub> surface treatment.

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# Contact Angles on Differently Treated SiO<sub>2</sub>



# Effects of SiO<sub>2</sub> Surface on Raman G-band



M. S. Dresselhaus et al., Nano Lett. 10(2010)751

K. Nagashio et al., IEDM (2010).

A strong interaction between graphene and SiO<sub>2</sub>.





F. Schwierz, Nature Nanotech. May 2010.

### Mobility is degraded as E<sub>G</sub> is opened.

### **Bi-layer Graphene**



J. B. Oostinga et al., Nature Materials 7 (2008) 151.

### Bi-layer graphene with double gates can open the gap!

### Intrinsic Challenges (2) - contact resistance -



$$R_{total} = R_{ch} + 2R_{contact}$$
$$R_{contact} = \frac{1}{2} \left( R_{total} - \rho_{channel} \frac{L}{W} \right)$$

K. Nagashio et al., IEDM (2009).

#### Contact area dependence of contact resistance.

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## **Current Crowding**



Current crowding should be considered in large contacts.

## Specific Contact Resistance

Cross-bridge Kelvin

$$R_{c} = \frac{V}{I} = \frac{\rho_{c\Box}}{dW}$$





Etched by O<sub>2</sub> plasma

contact resistivity

$$p_{c\Box} = ~ 5 \times 10^{-6} \Omega cm^2$$

Transfer length

$$d_{T} = \sqrt{\frac{\rho_{C\square}}{R_{sh}}} = ~1 \mu m$$

K. Nagashio et al., APL. 97(2010) 143514.

### **DOS Bottleneck**



A small number of seats available in the channel.

### Intrinsic Challenges (3) - quantum capacitance -



Z. Chen and J. Appenzeller, IEDM (2008)

#### Sub-nm CET is intrinsically difficult.

## **Output Characteristics**



#### Intrinsically no pinch-off due to no band-gap.

### **RF-Performance**



Y. M. Lin et al. Science 327(2010)662.

F. Schwierz, Nature Nanotech. May 2010.

 $f_{\tau}$  is comparable to existing RF devices.

## **Other Applications**



C. Chen, et al., Nature Nanotech. 4 (2009)861.

*F. Schedin, et al., Nature Mater. 6 (2007)652.* 

### Wafer Scale to Roll-to-Roll

#### SKKU + Samsung



#### Y. Lee et al., Nano Lett. 10 (2010) 490.



#### S. Bae et al, Nature Nanotech. 5 (2010)574.

## Far Beyond Conventional FETs

### **BiSFET** - Bilayer Pseudo Spin Field-Effect Transistor -

H. Min et al., Phys. Rev. B78 (2007)121401.

el-hole condensation through thin insulator.



**Ultra-low Power Switching !** 

# Summary

✓ Graphene is a really exciting material for both physicists and engineers.

Monolayer graphene shows very high mobility for both electron and hole.

✓ High frequency application seems more promising than digital one.

No band-gap and small DOS effects such as quantum capacitance and large contact resistance should be seriously concerned.

The graphene research is just booming up, and I believe it will shows different faces in a couple of years.

✓ Be optimistic about new materials for the present.